



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#1
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OFFICE OF PETITIONS

Applicant(s): Thomas R. Omstead and Karl B. Levy
Assignee: Novellus Systems, Inc.
Title: Atomic Layer Deposition Systems and Methods
Serial No.: 10/028,610 Filing Date: December 19, 2001
Examiner: M. Song Group Art Unit: 1765
Docket No.: M-11953 US

Irvine, California
September 23, 2003

Mail Stop Petitions
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

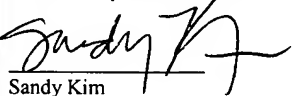
RESPONSE TO RESTRICTION REQUIREMENT

Dear Sir:

In response to the Restriction Requirement dated February 4, 2003, Applicants hereby elect to prosecute group I, process claims 1-11, 13-21, and 23-31. Applicants reserve the right to prosecute non-elected group II, product claims 12, 22, and 32 in a divisional application.

Applicants include a Petition to Revive with this response.

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Alexandria, VA 22313-1450, on September 23, 2003.


Sandy Kim

September 23, 2003

Respectfully submitted,



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